

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Shinji TOJO et al.

Appln. No.:

Filed: HEREWITH

For: A METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE STATEMENT

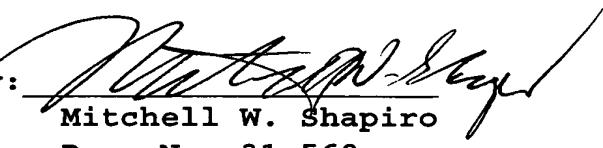
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Applicants wish to make of record the documents cited in prior Application No. 10/242,720 filed September 13, 2002, whether cited by Applicants or by the Patent Office. The documents are listed on the attached Form PTO-1449.

Respectfully submitted,

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January 12, 2004

FORM PTO-1449				Atty. Docket No. XA-9745A	Appn. No.		
LIST OF DOCUMENTS CITED BY APPLICANT				Applicant Shinji TOJO et al.			
				Filing Date HEREWITH	Group		
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-class	Filing Date
	AA	6,444,492	9/02	Ohta	438	108	
	AB	6,475,877	11/02	Saia et al.	438	460	
	AC	2001/0019852	9/01	Hashimoto	438	106	
	AD	2002/0058358	5/02	Jiang	438	118	
	AE	2001/0029062	10/01	Hashimoto	438	110	
	AF	2002/0013014	01/02	Jiang	438	106	
	AG	2002/0037605	3/02	Ninomiya et al.	438	125	
	AH						
	AI						
FOREIGN PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Country	Class	Sub-class	Translation
	AJ	2001-144144	5/25/01	Japan			Abstract
	AK	2000-124255	4/28/00	Japan			Abstract
	AL						
	AM						
	AN						
	AO						
OTHER (including author, title, date, pertinent pages, etc.)							
	AP						
	AQ						
	AR						
Examiner				Date Considered			
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							